INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 22, 2026

IGI Report Number	LG794663279
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	11.91 X 8.56 X 5.74 MM

GRADING RESULTS

Carat Weight	5.80 CARATS
Color Grade	F
Clarity Grade	VVS 1

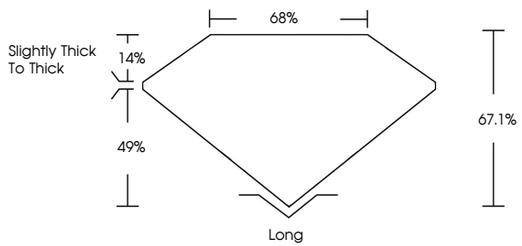
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794663279

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG794663279
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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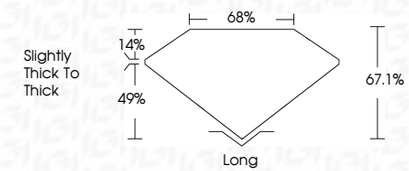

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IGI

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IGI Report No LG794663279
RECTANGULAR CUSHION MIXED CUT
11.91 X 8.56 X 5.74 MM

Carat Weight	5.80 CARATS
Color Grade	F
Clarity Grade	VVS 1
Depth	67.1%
Table	68%
Girdle	Slightly Thick To Thick
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794663279

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